

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto, et al.

Art Unit : 2814
Examiner : Theresa T. TEGHNOLOGY CENTER 2800

Serial No.: 09/941,367 Filed : August 28, 2001

: METHOD FOR PRODUCING INSULATED GATE THIN FILM

SEMICONDUCTOR DEVICE

Commissioner for Patents Washington, D.C. 20231

REVISED INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Title

A typographical error was discovered in the IDS mailed to the U.S. Patent and Trademark Office on September 9, 2002; specifically, the Japanese patent referenced as 5282869 should have been listed as 4282869. Attached is a copy of the PTO Form 1449 mailed on September 9, 2002 with the change indicated in red. Also attached is a revised PTO Form 1449.

This filing is being made before the receipt of a first Office action on the merits. No fee is required.

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR $\S1.8(a)$ that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

December 27

Deposit

Sharon Gebhart

Name of Person Signing Certificate

Attorney's Docket No.: 07977-010005 / US2941D1D1D1

Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

Please apply any additional charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: December 27, 2002

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